

Sut	stitute for form 1449A/B/	РТО			Complete if Known		
					Application Number	10/665,099-Conf. #6145	
l IN	NFORMATIO	N DI	SCLOS	SURE	Filing Date	September 17, 2003	
S	STATEMENT BY APPLICANT				First Named Inventor	Cem Basceri	
	***				Art Unit	2823	
	(Use as many sheets as necessary))	Examiner Name	W. M. Brewster	
Sheet	1	of	•	13	Attorney Docket Number	108298719US	

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